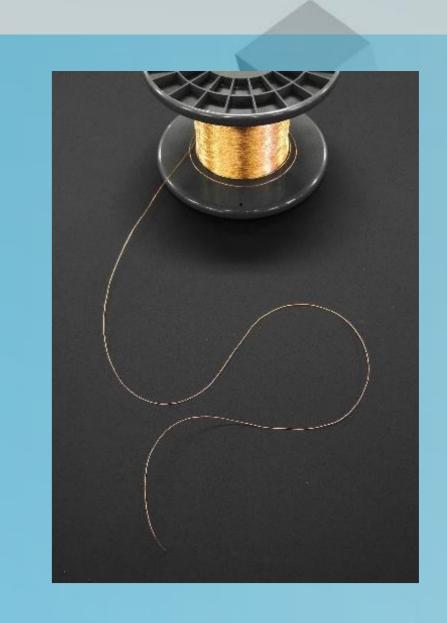
# ピエッラ®



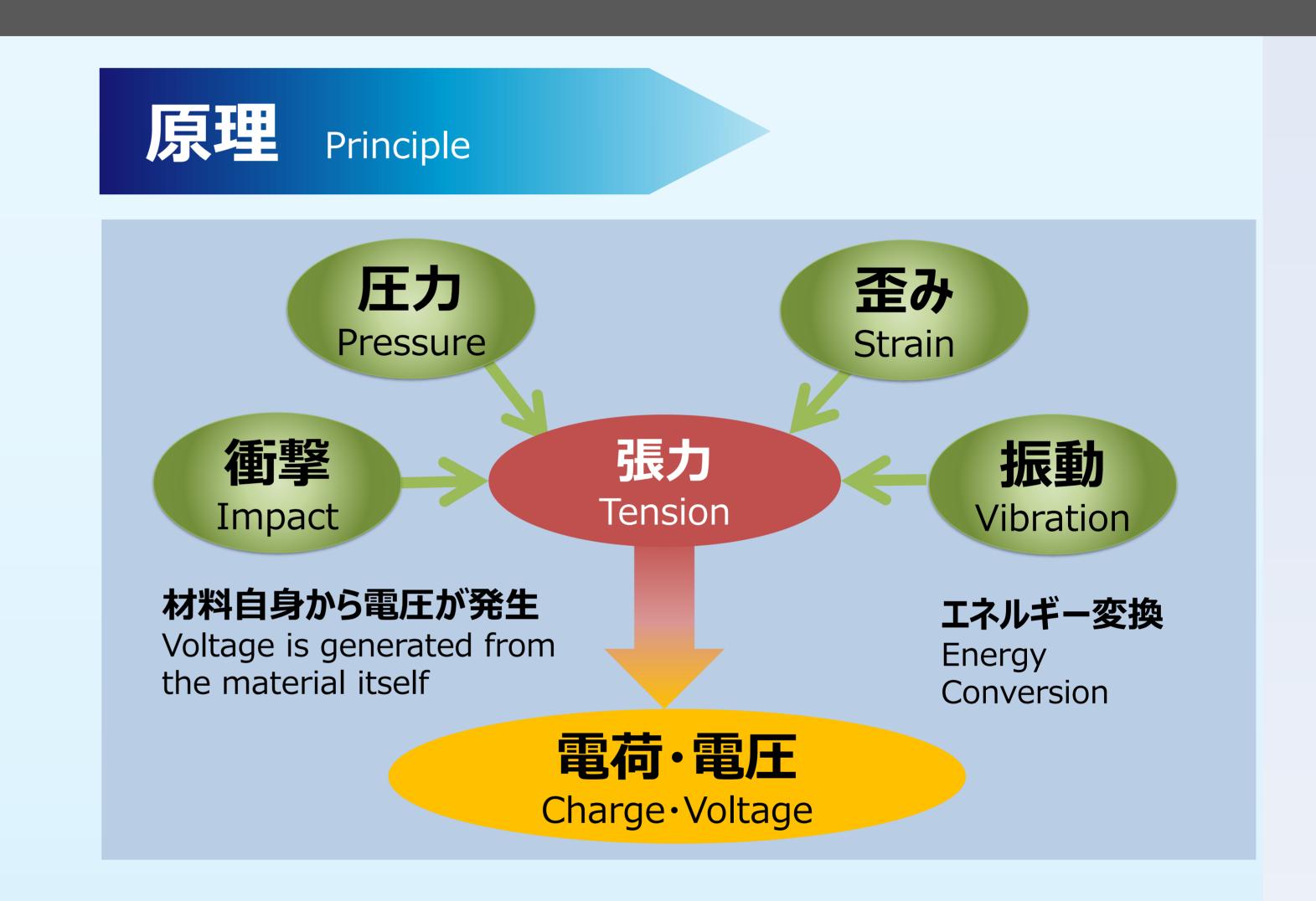
### 開発の狙い Development target

感度の高さ、柔軟性をもつ同軸線状構造を活かした接触、振動を検出するセンサ A sensor that detects contact and vibration using a high sensitivity, flexible coaxial linear structure.

# 特徵 Specification

微小な歪変化の検出 線・面・立体に適用可能 超音波領域の振動検出 Detection of tiny changes of strain, Simply fixable to 1D, 2D and 3D object, Detection of ultrasonic

# 構造 Structure 導体 Conductor piezo material conductor 中=0.4mm 同軸線構造(Coaxial Structure)

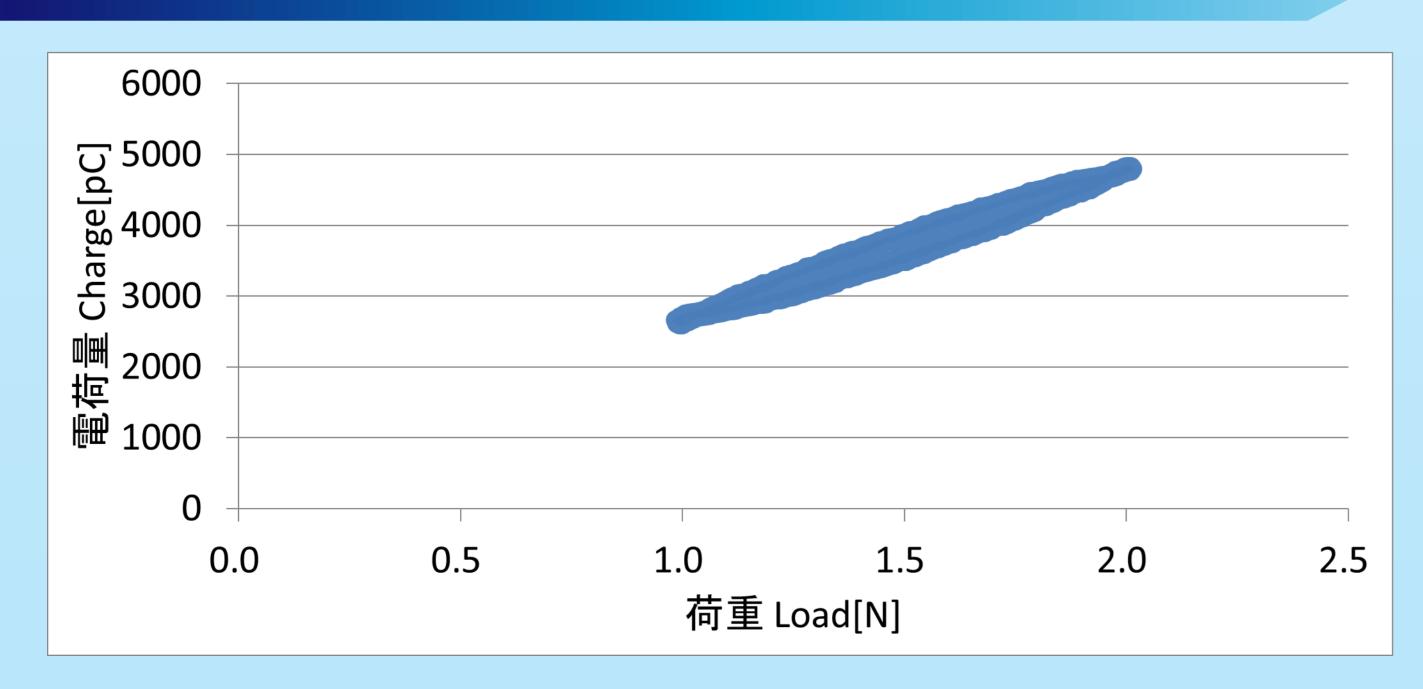


## 物性值※ Features and Specifications\*

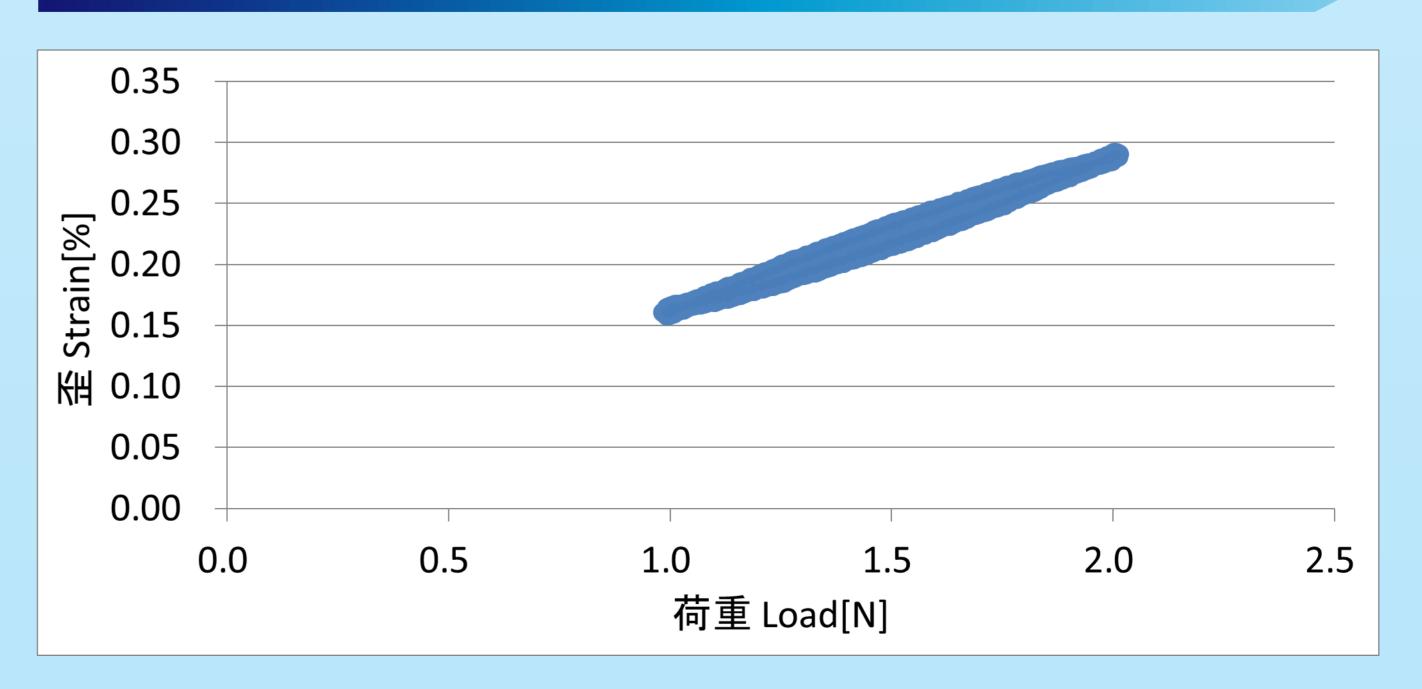
センサ径 Diameter	0.4mm
重量 Weight	0.6g/m
静電容量 Capacitance	4.6pF/cm
感度 Sensitivity	12pC/N·mm

使用張力範囲 Working Tension	~2.0N
破断強度 Breaking Strength	18N
応答周波数 Frequency Response	$\sim$ 125kHz
使用温度範囲 Operating Temperature	~60°C

## 可重·電荷特性 Load and Charge Characteristics\*



## 荷重·歪特性※ Load and Strain Characteristics\*



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